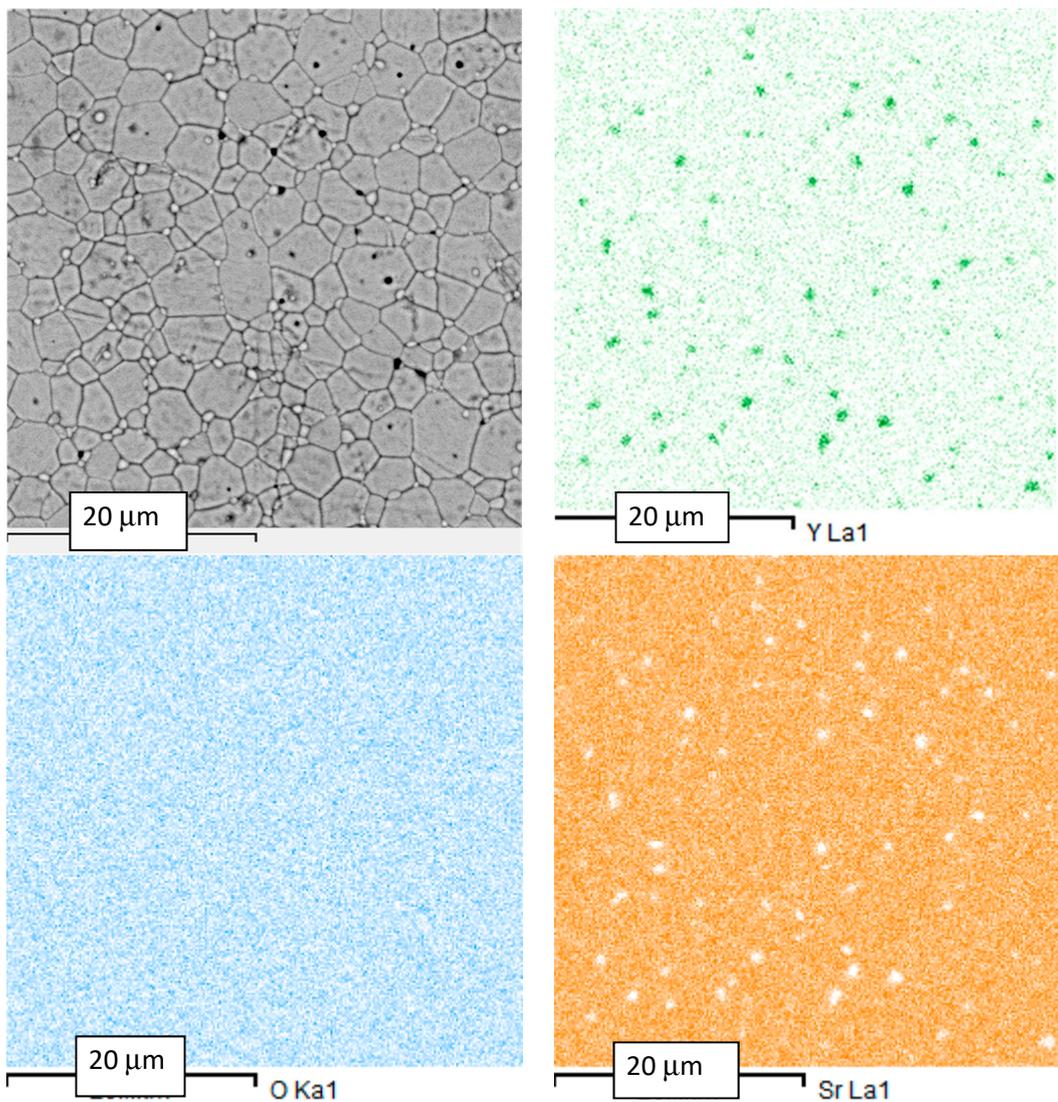


Supplementary Materials: Effect of A-Site Nonstoichiometry on Defect Chemistry and Electrical Conductivity of Undoped and Y-Doped SrZrO₃

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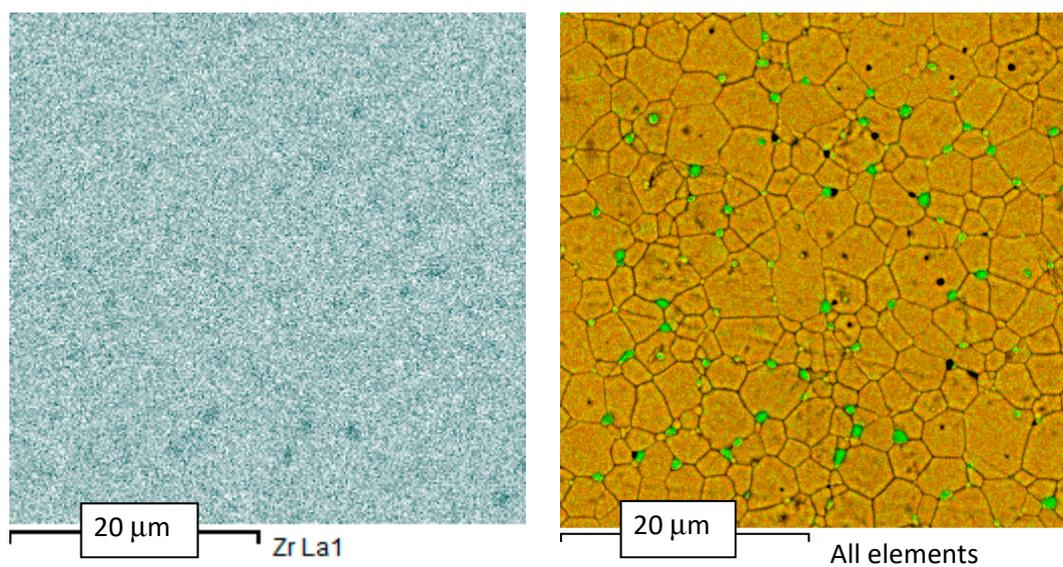
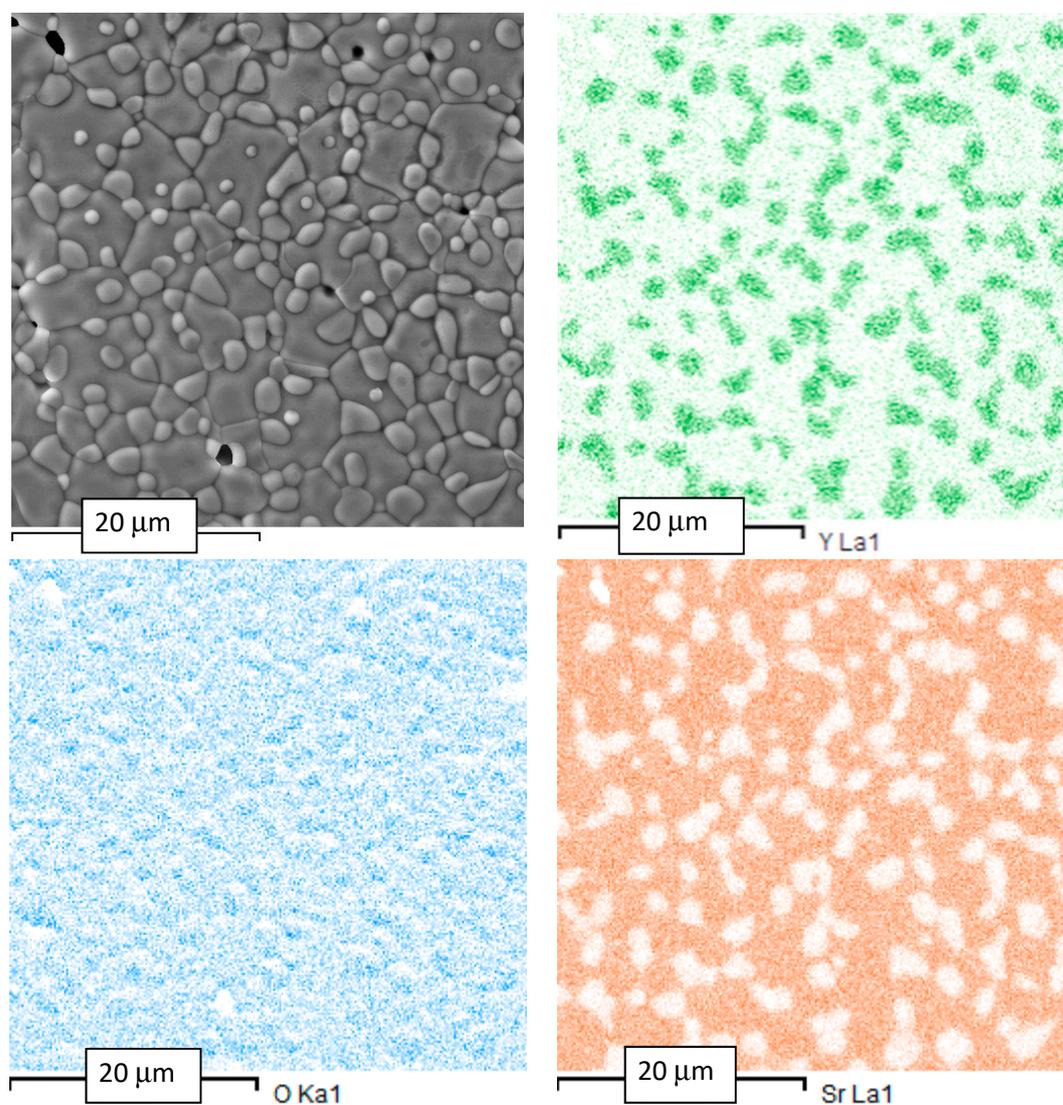


Figure S1. SEM image and EDX mapping of the elements on the surface of SZY0.94 after polishing and thermal etching at 1400 °C.



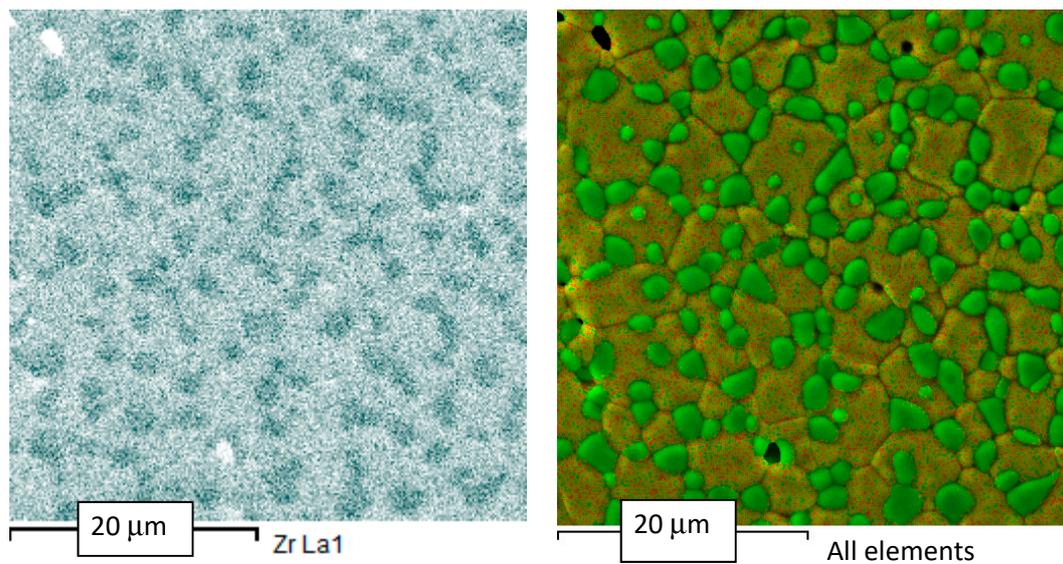


Figure S2. SEM image and EDX mapping of the elements on the surface of SZY0.94 after polishing and thermal etching at 1650 °C.

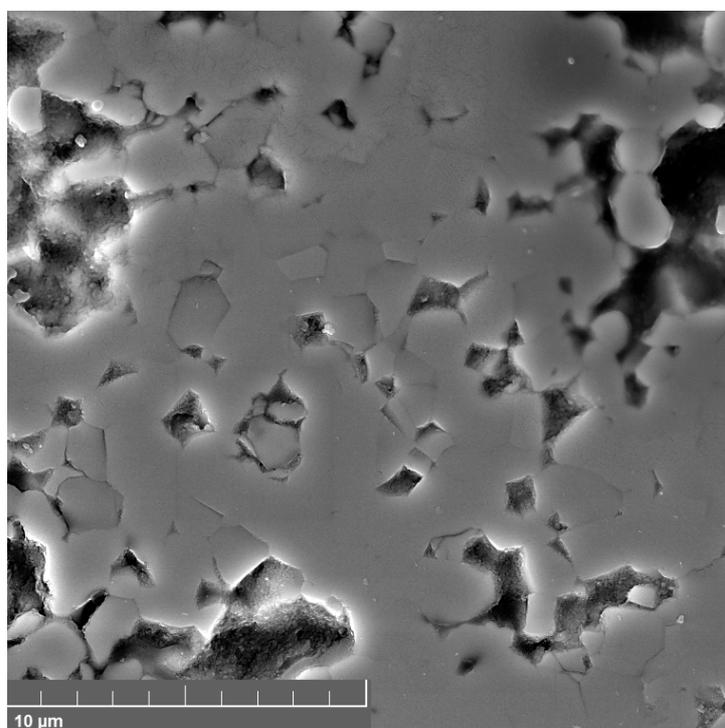


Figure S3. SEM image of as-polished cross-section of SZY1.00.